



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ogle, Robert B. et al.  
Assignee: Advanced Micro Devices, Inc.  
Title: Novel Oxidizing Pretreatment Of Flash ONO Nitride For Oxide Deposition  
Application No.: 10/010,280 Filing Date: December 5, 2001  
Examiner: Pizarro-Crespo, Marcos D. Group Art Unit: 2814  
Docket No.: M-7522 US

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FEB 19 2003

San Jose, California  
January 30, 2003

OFFICE OF THE SPECIAL  
PROGRAMS EXAMINER

COMMISSIONER FOR PATENTS  
Washington, D. C. 20231

REQUEST TO WITHDRAW FROM REPRESENTATION  
UNDER 37 CFR §10.40(b)(4)

Dear Sir:

Attorneys and agents of Skjerven Morrill LLP at 25 Metro Drive, Suite 700, San Jose, CA 95110 are of record in the above-cited application, and hereby request to withdraw from representation in this application under 37 C.F.R. §10.40(b)(4). This is a mandatory withdrawal because the practitioner in this application is discharged by our client. At the client's request, papers associated with this application are being transferred to another law firm. A new correspondence address is given below.

By this paper, all attorneys and agents of record in this application, including all attorneys and agents associated with Customer Numbers 24251 and 27869 as listed on the attached sheet, and all attorneys and agents of Skjerven Morrill LLP who have appeared in this application or were listed on any power of attorney submitted in the application, request to withdraw. The attorney of record signing below is signing on behalf of each and every such attorney and agent.

#914084 v1

-1-

Application No. 10/010,280

LAW OFFICES OF  
SKJERVEN MORRILL LLP  
25 METRO DRIVE  
SUITE 700  
SAN JOSE, CA 95110  
(408) 453-9200  
FAX (408) 453-7979

Please address all future correspondence regarding this application to:

Mike Farjami  
Farjami & Farjami  
16148 Sand Canyon  
Irvine, CA 92618  
Telephone: (949) 784-4600  
Facsimile: (949) 784-4601

A copy of this request is being mailed to Mike Farjami at the above address. A copy is also being mailed to our client, at the following address:


Advanced Micro Devices, Inc.  
One AMD Place, M/S 68  
P.O. Box 3453  
Sunnyvale, CA 94088-3453

An Official Action is pending in this application, and is due on February 28, 2003.

This response deadline is extendable under 37 C.F.R. 1.136(a) until May 29, 2003.

If Office personnel have any questions regarding this request for withdrawal they are invited to telephone the undersigned attorney at (408) 453-9200. This request is being submitted in triplicate.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on January 30, 2003.



Attorney for Applicant(s)

1/30/03

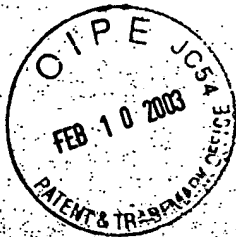
Date of Signature

Respectfully submitted,



Norman R. Klivans  
Attorney of Record  
Reg. No. 33,003





**COMMISSIONER FOR PATENTS**  
**Washington, D.C. 20231**

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**ENCLOSED:**

1. This Return Receipt Postcard
2. Request To Withdraw From Representation Under 37 CFR 10.40(b)(4)  
(2 pp.) in triplicate
3. Power of Attorney List (1 p.)

NRK/jmh

Dated: January 30, 2003

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